


O.I.P.E.		PATENT DATE
SCANNED	Q.A.	

APPLICATION NO. 09/910638	CONT/PRIOR D	CLASS 451	SUBCLASS 57	ART UNIT 3729 3023	EXAMINER Grant Smith
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Method and apparatus for chemical-mechanical polishing of microelectronic substrates with a carrier and slurry

PTO-2040
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 TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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